§ 1065.362 Non-stoichiometric raw exhaust FID O₂ interference verification.

(a) *Scope and frequency.* If you use FID analyzers for raw exhaust measurements from engines that operate in a non-stoichiometric mode of combustion (e.g., compression-ignition, lean-burn), verify the amount of FID O_2 interference upon initial installation and after major maintenance.

(b) *Measurement principles.* Changes in O_2 concentration in raw exhaust can affect FID response by changing FID flame temperature. Optimize FID fuel, burner air, and sample flow to meet this verification. Verify FID performance with the compensation algorithms for FID O_2 interference that you have active during an emission test.

(c) *System requirements.* Any FID analyzer used during testing must meet the FID O_2 interference verification according to the procedure in this section.

(d) *Procedure.* Determine FID O_2 interference as follows, noting that you may use one or more gas dividers to create the reference gas concentrations that are required to perform this verification:

(1) Select three span reference gases that contain a C_3H_8 concentration that you use to span your analyzers before emission testing. Use only span gases that meet the specifications of § 1065.750. You may use CH_4 span reference gases for FIDs calibrated on CH_4 with a nonmethane cutter. Select the three balance gas concentrations such that the concentrations of O_2 and N_2 represent the minimum, maximum, and average O_2 concentrations expected during testing. The requirement for using the average O_2 concentration can be removed if you choose to calibrate the FID with span gas balanced with the average expected oxygen concentration.

(2) Confirm that the FID analyzer meets all the specifications of § 1065.360.

(3) Start and operate the FID analyzer as you would before an emission test. Regardless of the FID burner's air source during testing, use zero air as the FID burner's air source for this verification.

(4) Zero the FID analyzer using the zero gas used during emission testing.

(5) Span the FID analyzer using a span gas that you use during emission testing.

(6) Check the zero response of the FID analyzer using the zero gas used during emission testing. If the mean zero response of 30 seconds of sampled data is within ±0.5% of the span reference value used in paragraph (d)(5) of this section, then proceed to the next step; otherwise restart the procedure at paragraph (d)(4) of this section.

(7) Check the analyzer response using the span gas that has the minimum concentration of O_2 expected during testing. Record the mean response of 30 seconds of stabilized sample data as $x_{O2minHC}$.

(8) Check the zero response of the FID analyzer using the zero gas used during emission testing. If the mean zero response of 30 seconds of stabilized sample data is within ±0.5% of the span reference value used in paragraph (d)(5) of this section, then proceed to the next step; otherwise restart the procedure at paragraph (d)(4) of this section.

(9) Check the analyzer response using the span gas that has the average concentration of O_2 expected during testing. Record the mean response of 30 seconds of stabilized sample data as $x_{O2avgHC}$.

(10) Check the zero response of the FID analyzer using the zero gas used during emission testing. If the mean zero response of 30 seconds of stabilized sample data is within ±0.5% of the span reference value used in paragraph (d)(5) of this section, proceed to the next step; otherwise restart the procedure at paragraph (d)(4) of this section.

(11) Check the analyzer response using the span gas that has the maximum concentration of O_2 expected during testing. Record the mean response of 30 seconds of stabilized sample data as $x_{O2maxHC}$.

(12) Check the zero response of the FID analyzer using the zero gas used during emission testing. If the mean zero response of 30 seconds of stabilized sample data is within ±0.5% of the span reference value used in paragraph (d)(5) of this section, then proceed to the next step; otherwise restart the procedure at paragraph (d)(4) of this section.

(13) Calculate the percent difference between $x_{O2maxHC}$ and its reference gas

concentration. Calculate the percent difference between $x_{O2avgHC}$ and its reference gas concentration. Calculate the percent difference between $x_{O2minHC}$ and its reference gas concentration. Determine the maximum percent difference of the three. This is the O_2 interference.

(14) If the O_2 interference is within ±2%, the FID passes the O_2 interference verification; otherwise perform one or more of the following to address the deficiency:

(i) Repeat the verification to determine if a mistake was made during the procedure.

(ii) Select zero and span gases for emission testing that contain higher or lower O_2 concentrations and repeat the verification.

(iii) Adjust FID burner air, fuel, and sample flow rates. Note that if you adjust these flow rates on a THC FID to meet the O_2 interference verification, you have reset RF_{CH4} for the next RF_{CH4} verification according to §1065.360. Repeat the O_2 interference verification after adjustment and determine RF_{CH4}.

(iv) Repair or replace the FID and repeat the O_2 interference verification.

(v) Demonstrate that the deficiency does not adversely affect your ability to demonstrate compliance with the applicable emission standards.

[70 FR 40516, July 13, 2005, as amended at 73 FR 37309, June 30, 2008]

§ 1065.365 Nonmethane cutter penetration fractions.

(a) *Scope and frequency.* If you use a FID analyzer and a nonmethane cutter (NMC) to measure methane (CH_4), determine the nonmethane cutter's penetration fractions of methane, PF_{CH4}, and ethane, PF_{C2H6}. As detailed in this section, these penetration fractions may be determined as a combination of NMC penetration fractions and FID analyzer response factors, depending on your particular NMC and FID analyzer configuration. Perform this verification after installing the nonmethane cutter. Repeat this verification within 185 days of testing to verify that the catalytic activity of the cutter has not deteriorated. Note that because nonmethane cutters can deteriorate rapidly and without warning if they are operated outside of certain ranges of gas concentrations and outside of certain temperature ranges, good engineering judgment may dictate that you determine a nonmethane cutter's penetration fractions more frequently.

(b) *Measurement principles.* A nonmethane cutter is a heated catalyst that removes nonmethane hydrocarbons from an exhaust sample stream before the FID analyzer measures the remaining hydrocarbon concentration. An ideal nonmethane cutter would have a methane penetration fraction, PF_{CH4}, of 1.000, and the penetration fraction for all other nonmethane hydrocarbons would be 0.000, as represented by PF_{C2H6}. The emission calculations in §1065.660 use the measured values from this verification to account for less than ideal NMC performance.

(c) *System requirements.* We do not limit NMC penetration fractions to a certain range. However, we recommend that you optimize a nonmethane cutter by adjusting its temperature to achieve a PF_{CH4} >0.85 and a PF_{C2H6} <0.02, as determined by paragraphs (d), (e), or (f) of this section, as applicable. If we use a nonmethane cutter for testing, it will meet this recommendation. If adjusting NMC temperature does not result in achieving both of these specifications simultaneously, we recommend that you replace the catalyst material. Use the most recently determined penetration values from this section to calculate HC emissions according to §1065.660 and §1065.665 as applicable.

(d) *Procedure for a FID calibrated with the NMC.* The method described in this paragraph (d) is recommended over the procedures specified in paragraphs (e) and (f) of this section. If your FID arrangement is such that a FID is always calibrated to measure CH_4 with the NMC, then span that FID with the NMC using a CH_4 span gas, set the product of that FID's CH_4 response factor and CH_4 penetration fraction, $RFPF_{CH4[NMC–FID]}$, equal to 1.0 for all emission calculations, and determine its combined ethane (C_2H_6) response factor and penetration fraction, $RFPF_{C2H6[NMC–FID]}$ as follows:

(1) Select CH_4 and C_2H_6 analytical gas mixtures and ensure that both mixtures meet the specifications of